



ELECTRONIC COPY

LG636483429
Report verification at igi.org

LABORATORY GROWN DIAMOND REPORT

May 28, 2024
IGI Report Number **LG636483429**
Description **LABORATORY GROWN DIAMOND**
Shape and Cutting Style **EMERALD CUT**
Measurements **12.28 X 8.61 X 5.75 MM**

GRADING RESULTS

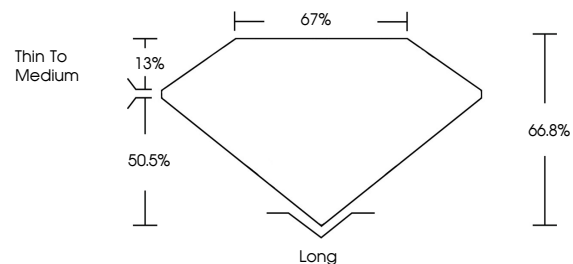
Carat Weight **6.03 CARATS**
Color Grade **G**
Clarity Grade **VVS 2**

ADDITIONAL GRADING INFORMATION

Polish **EXCELLENT**
Symmetry **EXCELLENT**
Fluorescence **NONE**
Inscription(s) **IGI LG636483429**

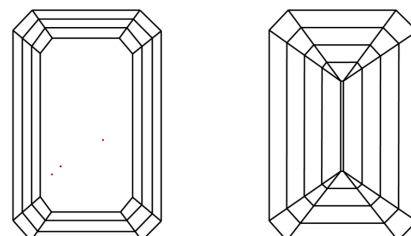
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

PROPORTIONS



Sample Image Used

CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.
Green symbols indicate external characteristics.

COLOR

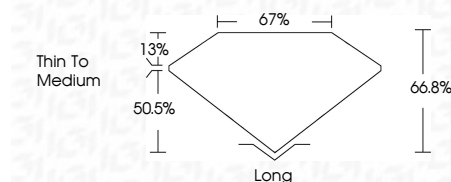
D E F G H I J Faint Very Light Light

CLARITY

| | | | | |
|---------------------|-----------------------------|------------------------|-------------------|------------------|
| IF | VS ¹⁻² | VS ¹⁻² | SI ¹⁻² | I ¹⁻³ |
| Internally Flawless | Very Very Slightly Included | Very Slightly Included | Slightly Included | Included |



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IGI

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EMERALD CUT

12.28 X 8.61 X 5.75 MM

Carat Weight **6.03 CARATS**
Color Grade **G**
Clarity Grade **VVS 2**
Depth **66.8%**
Table **67%**
Girdle **Thin To Medium**

Culet **Long**
Polish **EXCELLENT**
Symmetry **EXCELLENT**
Fluorescence **NONE**
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